



TO 2800 MAIL ROM <u>ATES PATENT & TRADEMARK OFFICE</u>

IN RE APPLICATION OF:

KIMIHIRO MATSUSE ET AL.

: GROUP ART UNIT: 2814

SERIAL NO: 09/530,588

CPA FILED: Herewith

: EXAMINER: QUACH, T.

FOR: WIRING STRUCTURE OF SEMI-

CONDUCTOR DEVICE, ELECTRODE, AND METHOD FOR FORMING THEM

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Responsive to the Official Action of June 4, 2002, please amend the above-identified application as follows:

IN THE SPECIFICATION

Page 1, please replace line 1 to read as follows:

TITLE OF THE INVENTION

Page 1, line 2, please delete the title in its entirety and substitute therefor:

METHOD OF FORMING SEMICONDUCTOR WIRING STRUCTURES

IN THE CLAIMS

Please cancel claims 63-88 without prejudice or disclaimer.

Please add new Claims 89-111.